

<b>Notice of References Cited</b>	Application/Control No. 10/709,849		Applicant(s)/Patent Under Reexamination LIN, CHE-LI	
	Examiner Seokyun Moon		Art Unit 2629	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0227895	11-2004	Yoo et al.	349/152
*	B	US-2004/0085371	05-2004	Lee et al.	346/045
*	C	US-2004/0113881	06-2004	Kim, Hong Chul	345/097
*	D	US-2004/0164943	08-2004	Ogawa et al.	345/092
	E	US-			
	F	US-			
	G	US-			
	H	US-			
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	J	US-			
	K	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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